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LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicants:

John M. White and Alexander Lerner

Filing Date:

Herewith

Group:

jc929 U.S. PTO
09/816807
03/23/01

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
PRC	AA	5,828,012	10/27/98	Repolleet et al.	—	—	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
PRC	AL	JP 8-158073	06/18/96	Japan	—	—		X
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

Examiner

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Date Considered

1/30/03

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.